Unification of the metal-insulator transitions driven by the impurity concentration and by the magnetic field in arsenic-doped germanium

I. Shlimak, M. Kaveh, R. Ussyshkin, V. Ginodman, and L. Resnick

Jack and Pearl Resnick Institute of Advanced Technology, Department of Physics, Bar-Ilan University, Ramat-Gan 52900, Israel

(Received 19 September 1996; revised manuscript received 21 October 1996)

We show that one can unify the scaling behavior of the conductivity in Ge:As in the vicinity of the metal-insulator transition driven either by the concentration of impurities N or by the magnetic field B by introducing a new scaling variable $U = [(N/N_c) - (B/B^*) - 1]$, where both the critical impurity concentration N_c and the characteristic magnetic field B^* are constant. [S0163-1829(97)10004-2]

The metal-insulator transition (MIT) has been the subject of intensive theoretical and experimental investigation for many years.¹ According to the scaling theory for doped semiconductors,² the conductivity at zero temperature $\sigma(0) = \sigma(T \rightarrow 0)$, when plotted as a function of the impurity concentration *N*, is equal to zero on the insulating side of the MIT and remains finite on the metallic side, obeying a power law in the vicinity of the transition

$$\sigma(0) \propto [(N/N_c) - 1]^{\mu} \tag{1}$$

where N_c is the critical-impurity concentration and μ is the critical-conductivity exponent. The theory² predicts $\mu = 1$. We will refer to this transition as *N*-MIT. For barely metallic samples with $N > N_c$, the MIT will occur upon the application of a critical magnetic field B_c , because a strong magnetic field leads to the shrinkage of the electron wave function. Scaling behavior of the conductivity is also expected in the neighborhood of this magnetic-field-driven metal-insulator transition (*B*-MIT):

$$\sigma(0) \propto [1 - (B/B_c)]^{\nu}, \qquad (2)$$

where ν is the critical exponent.¹ Most theoretical work^{1,3-6} predicts that the critical exponents should be equal to unity for both *N*-MIT and *B*-MIT, i.e., $\nu = \mu = 1$.

B-MIT has been studied for different doped semiconductors. There are many references on this subject. Therefore, we limit ourselves to investigations made in typical semiconductors, such as Ge,⁷⁻⁹ GaAs,¹⁰⁻¹² InSb,^{11,13} and Si,¹⁴⁻¹⁸ where the temperature dependencies of the conductivity $\sigma(T)$ have been measured at fixed magnetic fields. *B*-MIT in the form (2) was described in Refs. 7 and 10 and ν was found to be close to unity. Regarding the dependence of N_c on *B*, inconsistent results have been obtained: in Ref. 17 it was found that for Si:B, N_c does not change at B=1 T and increases slightly at B=7.5 T, whereas, in Si:P,¹⁸ it was found that N_c is the same at B=0 and 8 T. For Ge:Sb, an increase of N_c was observed in Ref. 8 at B=4 T; in Ref. 9 it was found that $N_c(B)-N_c(0) \propto B^{1/2}$ in weak fields (B < 2 T).

In this work, we present the results of an investigation of the MIT, driven by the impurity concentration and by the magnetic field in Ge:As. The *N*-MIT in this series of samples was studied in our previous paper,¹⁹ where we found that

 $N_c = 3.50 \times 10^{17}$ cm⁻³ and $\mu = 1$. Here we present the results of an investigation of the *B*-MIT. We show that $\nu = 1$, and the values of B_c increase linearly with $\Delta N \equiv N - N_c$:

$$B_c = B^*(\Delta N/N_c). \tag{3}$$

Finally, we show that *N*-MIT and *B*-MIT can be unified by introducing a new variable

$$U = [(N/N_c - 1)(1 - B/B_c)].$$
(4)

Using Eq. (3), one can rewrite U in the form

$$U = [(N/N_c) - (B/B^*) - 1].$$
(5)

As a result, the unified MIT $\sigma(0) \propto U^{\mu}$, $\mu = 1$ can be characterized by only two parameters, N_c and B^* , which are constant.

The samples of uncompensated Ge, metallurgically doped by As with a concentration of impurities close to the MIT, were cut from crystals grown by the Czochralski method. The temperature-dependent data were obtained by a fourprobe method using a dilution refrigerator combined with a superconducting magnet for measurements down to 100 mK in magnetic fields up to 9 T. In the vicinity of the MIT, the concentration of impurities measured by the Hall effect may not be equal to the effective concentration N^* responsible for the low-temperature conductivity because of the sample inhomogeneity. Therefore, we calculated N^* directly from the low-temperature resistance data using the method and scale proposed in Ref. 20.

The *N*-MIT for the series of Ge:As samples in zero magnetic field has been shown in Fig. 1 of Ref. 19. Figure 1 of the present paper shows the *B*-MIT for one of the sample of Ge:As with $N=4.60\times10^{17}$ cm⁻³. One can see that for both kinds of transitions, in the vicinity of the MIT, the conductivity $\sigma(T)$ takes the form $\sigma(T)=a+bT^{1/3}$ and crosses the MIT at a critical concentration $N=N_c$ or at a critical magnetic field $B=B_c$ where $\sigma(T)=bT^{1/3}$. This result is in agree-

1303



FIG. 1. Temperature dependence of the conductivity of one sample of Ge:As with $N=4.60\times10^{17}$ cm⁻³ in different magnetic fields *B*. Magnetic field from top to bottom (in T): 0, 1, 2, 3, 4, 5, 6, 7, and 8. The "critical field" $B_c=5$ T, the straight line corresponds to $\sigma(T)=bT^{1/3}$.

ment with the Aronov-Altshuler model,²¹ which predicts that at the critical point of the MIT the temperature dependence of conductivity must obey $\sigma(T) = b T^{1/3}$.

In order determine the critical index ν , we plot $\sigma(0) = \sigma(T \rightarrow 0)$ as a function of the scaling variable $[1 - (B/B_c)]$. This dependence is shown in inset (a) to Fig. 2. The data of $\sigma(0)$ were obtained by extrapolating the straight lines $\sigma(T) \propto T^{1/3}$ to T=0. To avoid the need to extrapolate to T=0, which is the main source of inaccuracy (especially due to the lack of straight lines), we consider the conductivity of any sample in the "critical regime," i.e., at $B=B_c$, as a ground level of conductivity, and instead of $\sigma(0)$, we plot the exact measured quantities $\Delta \sigma(T^*) = \sigma_B(T^*) - \sigma_{B_1}(T^*)$ at temperatures T^* , where the law $\sigma(T) \propto T^{1/3}$ is observed. The data for $\Delta \sigma(T^*)$ at $T^*=0.1$ and 0.216 K are also shown in inset (a) to Fig. 2. One can see that the obtained value of $\nu = 1$ does not depend on this replacement. This is due to the fact that in the immediate vicinity of the MIT, all the curves for $\sigma(T)$ are almost parallel (see Fig. 1) and therefore differences in the temperature corrections to the conductivity at fixed T are much smaller than those caused by changing the scaling variable B. This gives us reason to plot the values of $\Delta \sigma(T^*)$, obtained by sweeping magnetic field at fixed temperature. The result of this plot is presented in Fig. 2. One sees that $\nu = 1$, in accordance with the theoretical prediction.

Inset (b) shows that B_c increases linearly as a function of $N: B_c = B^*(\Delta N/N_c)$, with $B^* = 15$ T for Ge:As. This allows us to propose the unification of both *N*-MIT and *B*-MIT by introducing a new scaling variable $U = [(N/N_c - 1)(1 - B/B_c)]$. Taking Eq. (3) into account, one can rewrite *U* for uncompensated samples in the form given by Eq.



FIG. 2. Dependence of $\Delta \sigma(T^*)$ at $T^* = 0.216$ K as a function of $[1 - (B/B_c)]$ for one sample of Ge:As $(N = 5.38 \times 10^{17} \text{ cm}^{-3}, B_c = 8 \text{ T})$. Inset (a) shows the scaling dependencies of $\sigma(0)$, (1) and $\Delta \sigma(T^*)$ measured at $T^* = 0.1$ K (2) and at 0.216 K (3) for the sample of Ge:As $(N = 4.60 \times 10^{17} \text{ cm}^{-3}, B_c = 5 \text{ T})$. The straight line corresponds to $\nu = 1$. Inset (b) shows the dependence of B_c on ΔN for a series of samples of Ge:As.

(5), $U = [(N/N_c) - (B/B^*) - 1]$. Knowledge of B^* and N_c allows us to calculate U for any sample with $N > N_c$ and $B < B_c$ and plot $\sigma(0)$ or $\Delta \sigma(T^*)$ as a function of U. We normalize the values of $\sigma(0)$ and plot the dimensionless ra-



FIG. 3. Normalized scaling conductivity $\Delta \sigma/\tilde{\sigma}$ for Ge:As vs new universal variable $U = [(N/N_c) - (B/B^*) - 1]$. 1, 2, *B*-MIT for two samples of Ge:As with N = 5.38 and 4.17×10^{17} cm⁻³ $(N_c = 3.50 \times 10^{17}$ cm⁻³, $B^* = 15$ T); 3, *N*-MIT for series of Ge:As at B = 0.

tio $\sigma(0)/\tilde{\sigma}$ or $\Delta\sigma/\tilde{\sigma}$ where $\tilde{\sigma}=C_0(E^2/\hbar)N_c^{1/3}$ is the Mott minimum metallic conductivity. The result of this procedure is shown on Fig. 3. (The adjustable numerical coefficient was chosen for Ge to be $C_0=0.32$, so for Ge:As $\tilde{\sigma}\cong55$ S/cm.) One can see from Fig. 3 that all the data exhibit universal linear scaling behavior: $\Delta\sigma/\tilde{\sigma}=U^{\mu}$, $\mu=1$. This plot includes also the data for *N*-MIT at B=0.¹⁹ It means that in doped Ge:As the *N*-MIT and the *B*-MIT can be unified by introducing a new scaling variable *U*.

- ¹N. F. Mott, *Metal-Insulator Transitions*, 2nd ed. (Taylor & Francis, London, 1990); N. F. Mott and M. Kaveh, Adv. Phys. **34**, 329 (1985).
- ²E. Abrahams, P. W. Anderson, D. C. Licciardello, and T. V. Ramakrishnan, Phys. Rev. Lett. **42**, 693 (1979); P. A. Lee and T. V. Ramakrishnan, Rev. Mod. Phys. **57**, 287 (1985).
- ³Y. Imry and Y. Gefen, Philos. Mag. B **50**, 203 (1984).
- ⁴A. M. Finkel'stein, Zh. Eksp. Teor. Fiz. **84**, 168 (1983) [Sov. Phys. JETP **57**, 97 (1983)]; **86**, 367 (1984) [**59**, 212 (1984)].
- ⁵C. Castellani, G. Kotliar, and P. A. Lee, Phys. Rev. Lett. **59**, 323 (1987).
- ⁶C. Castellani, C. Di Castro, P. A. Lee, and M. Ma, Phys. Rev. B **30**, 527 (1984).
- ⁷R. M. Westervelt, M. J. Burns, P. F. Hopkins, A. J. Rimberg, and G. A. Thomas, in *Anderson Localization*, edited by T. Ando and H. Fukuyama (Springer-Verlag, Berlin, 1988), p. 33.
- ⁸Y. Ootuka, H. Matsuoka, and S. Kobayashi, in Anderson Localization (Ref. 7), p. 40.
- ⁹T. F. Rosenbaum, S. B. Field, and R. N. Bhatt, Europhys. Lett. 10, 269 (1989).
- ¹⁰M. C. Malliepaard, M. Pepper, R. Newbury, J. E. F. Frost, D. C. Peacock, D. C. Ritchie, and G. A. C. Jones, Phys. Rev. B **39**, 1430 (1989); Phys. Rev. Lett. **61**, 369 (1988).

This research was supported in part by the Israel Science Foundation (Grant No. 519/94-1) and by Grant No. I-319-199.07, from the German-Israeli Foundation for Scientific Research and Development. We are also grateful to the Eric and Sheila Samson Chair of Semiconductor Technology for financial support. We thank M. Lyubalin for growing doped Ge crystals, G. Citver for providing us with vacuum and cryogenic support and experiment automation, and D. Khmelnitskii for fruitful discussions.

- ¹¹D. J. Newson and M. Pepper, J. Phys. C 19, 3983 (1986).
- ¹²K.-J. Friedland, A. N. Ionov, R. Rentzsch, C. Gladun, and H. Vinzelberg, J. Phys. Condens. Matter 2, 3759 (1990).
- ¹³R. Mansfield, M. Abdul-Gader, and P. Fozooni, Solid-State Electron. 28, 109 (1985).
- ¹⁴A. R. Long and M. Pepper, J. Phys. C 17, L425 (1984).
- ¹⁵W. N. Shafarman, T. G. Castner, J. S. Brooks, K. P. Martin, and M. J. Naughton, Phys. Rev. Lett. 56, 980 (1986).
- ¹⁶S. Bogdanovich, P. Dai, and M. P. Sarachik, Phys. Rev. Lett. 74, 2543 (1995).
- ¹⁷P. Dai, Y. Zhang, and M. P. Sarachik, Phys. Rev. Lett. **67**, 136 (1991); Phys. Rev. B **45**, 3984 (1992).
- ¹⁸P. Dai, Y. Zhang, S. Bogdanovich, and M. P. Sarachik, Phys. Rev. B 48, 4941 (1993).
- ¹⁹I. Shlimak, M. Kaveh, R. Ussyshkin, V. Ginodman, and L. Resnick, Phys. Rev. Lett. **77**, 1103 (1996).
- ²⁰I. Shlimak, R. Ussyshkin, L. Resnick, and V. Ginodman, Appl. Phys. A **61**, 115 (1995).
- ²¹B. L. Altshuler and A. G. Aronov, Zh. Éksp. Teor. Fiz. 77, 2028 (1979) [Sov. Phys. JETP 50, 968 (1979)]; Pis'ma Zh. Éksp. Teor. Fiz. 30, 514 (1979) [JETP Lett. 30, 482 (1979)]; Solid State Commun. 30, 115 (1979).